

Photon-based Characterization of Single Ion Geiger Mode Avalanche Detectors: Experiments and Simulations

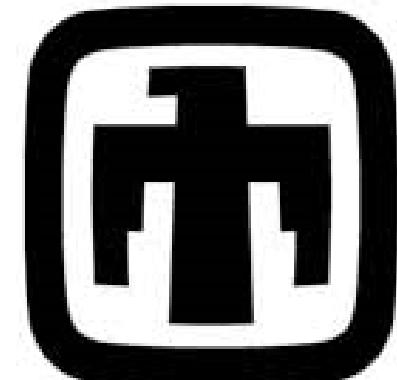
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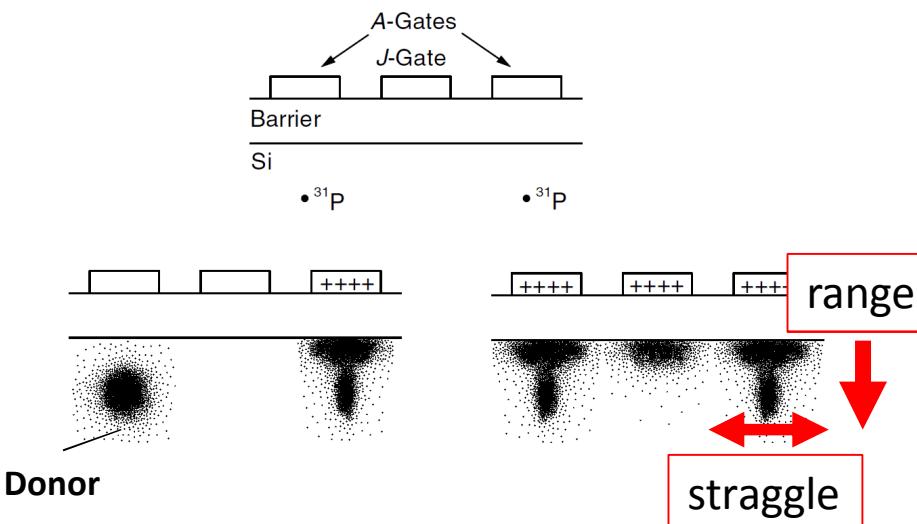


**U.S. DEPARTMENT OF
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SAND:

Quantum computer as an array of donors

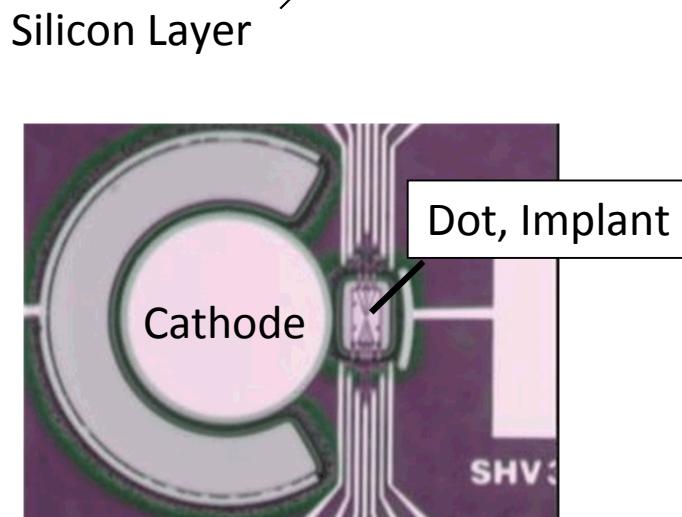
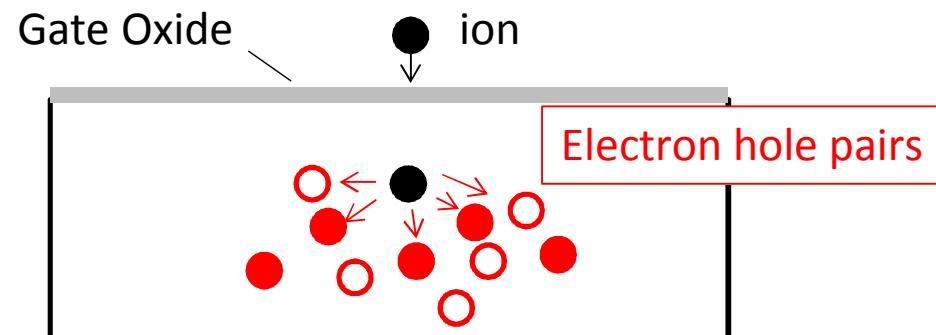


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Range/Straggle must be small
Lower energy: smaller range, straggle

Fabrication of arrays of single donors can be achieved through ion implantation

Challenge: detect very low energy ion implants at shallow depths with minimal straggle

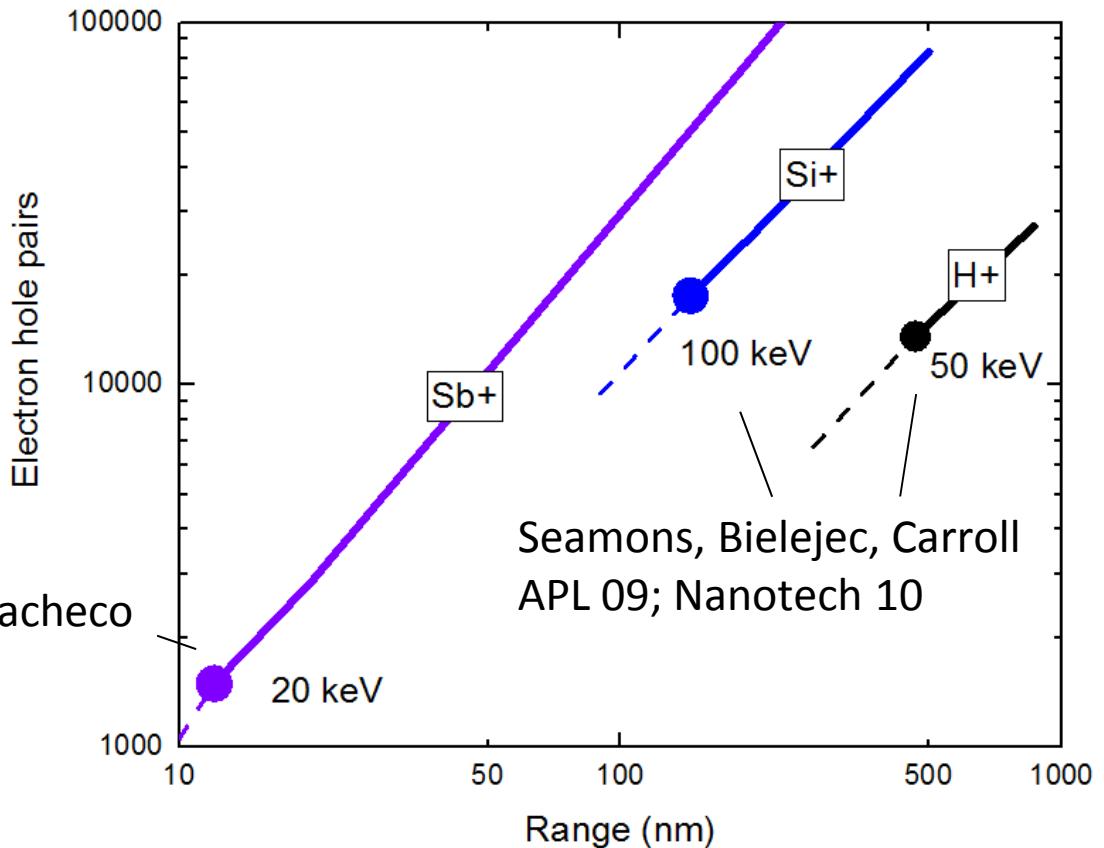


Detector + Dot

Singh, Pacheco

Shallow, low-straggles implants require detection of very small number of electron hole pairs

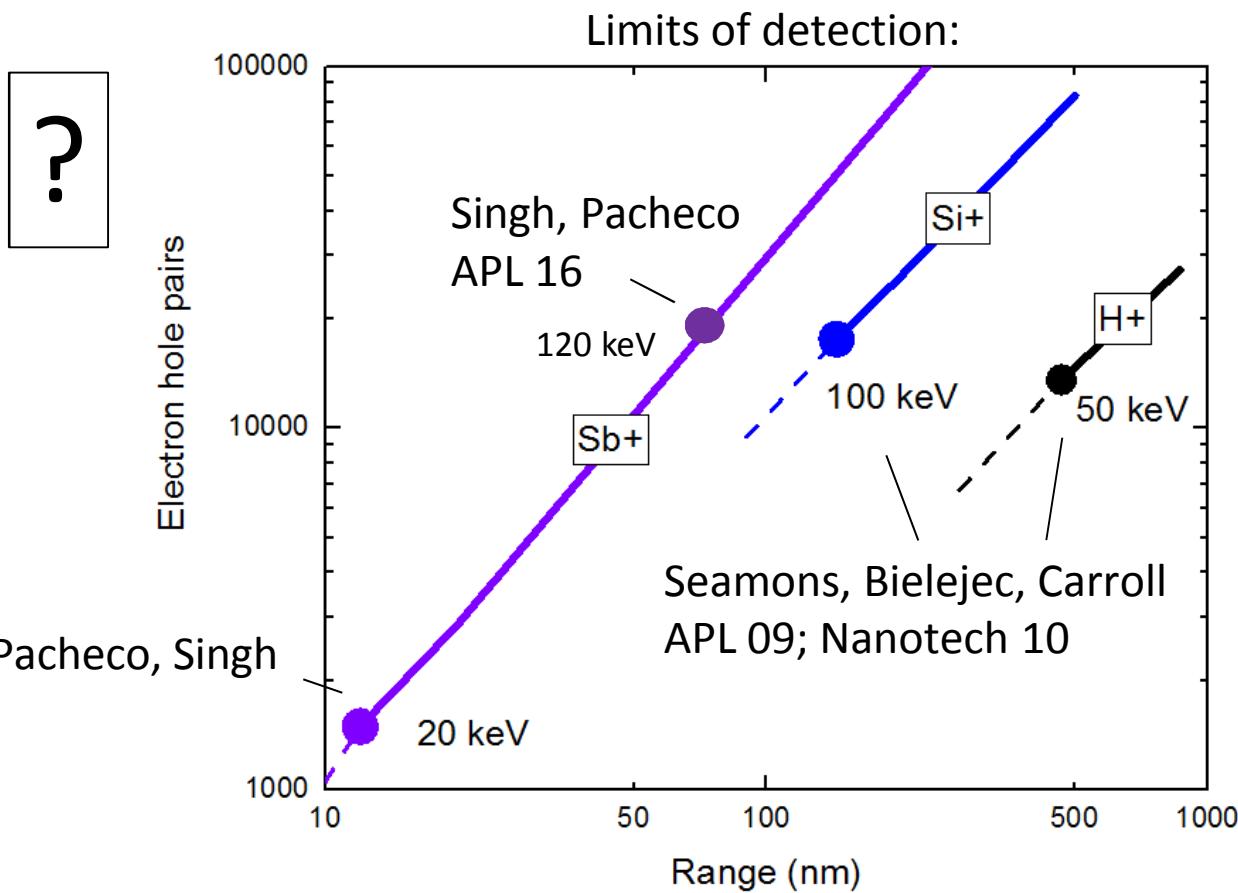
Detection in the few-ion limit



How do we improve detection?

Different species have different EH pair limits at different ranges

What are the limiting factors?

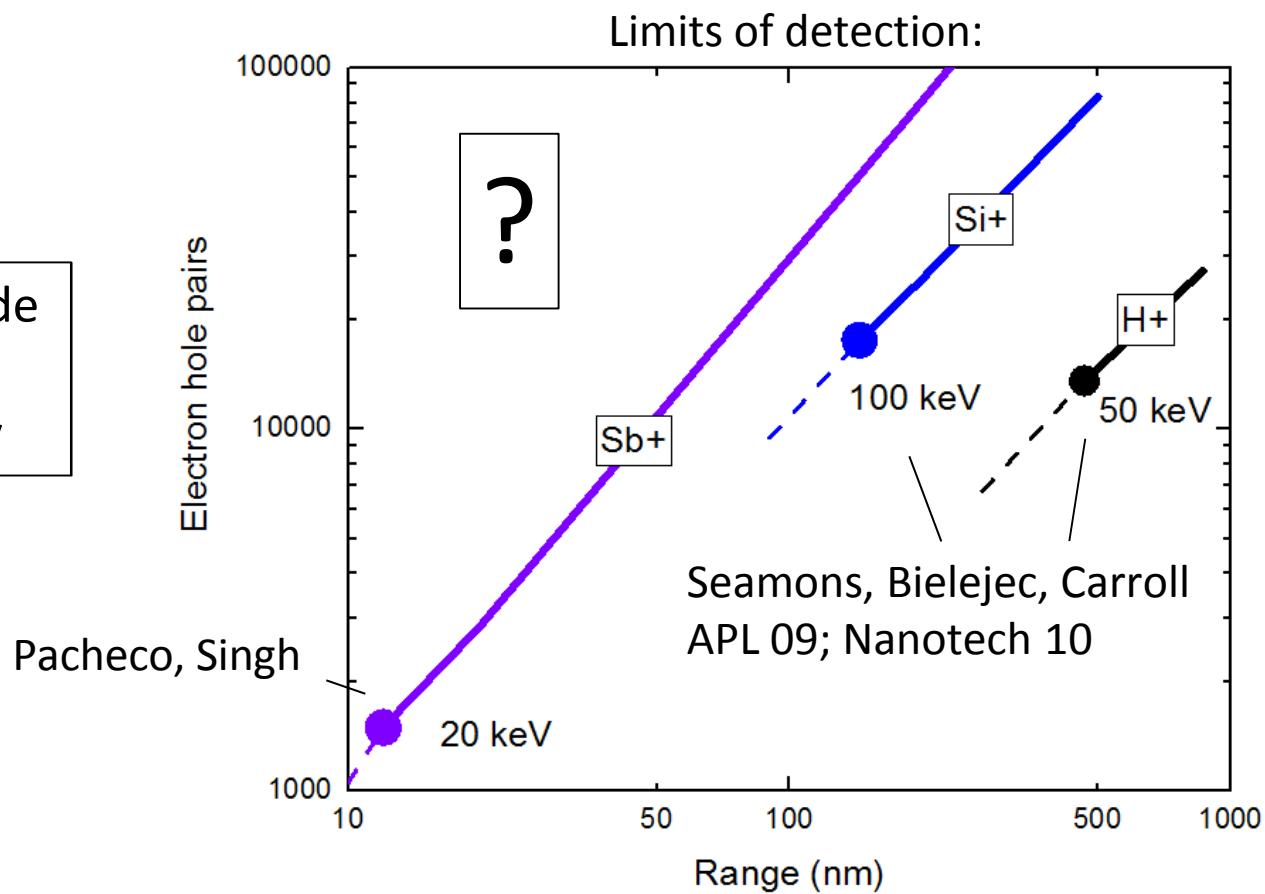


This work:

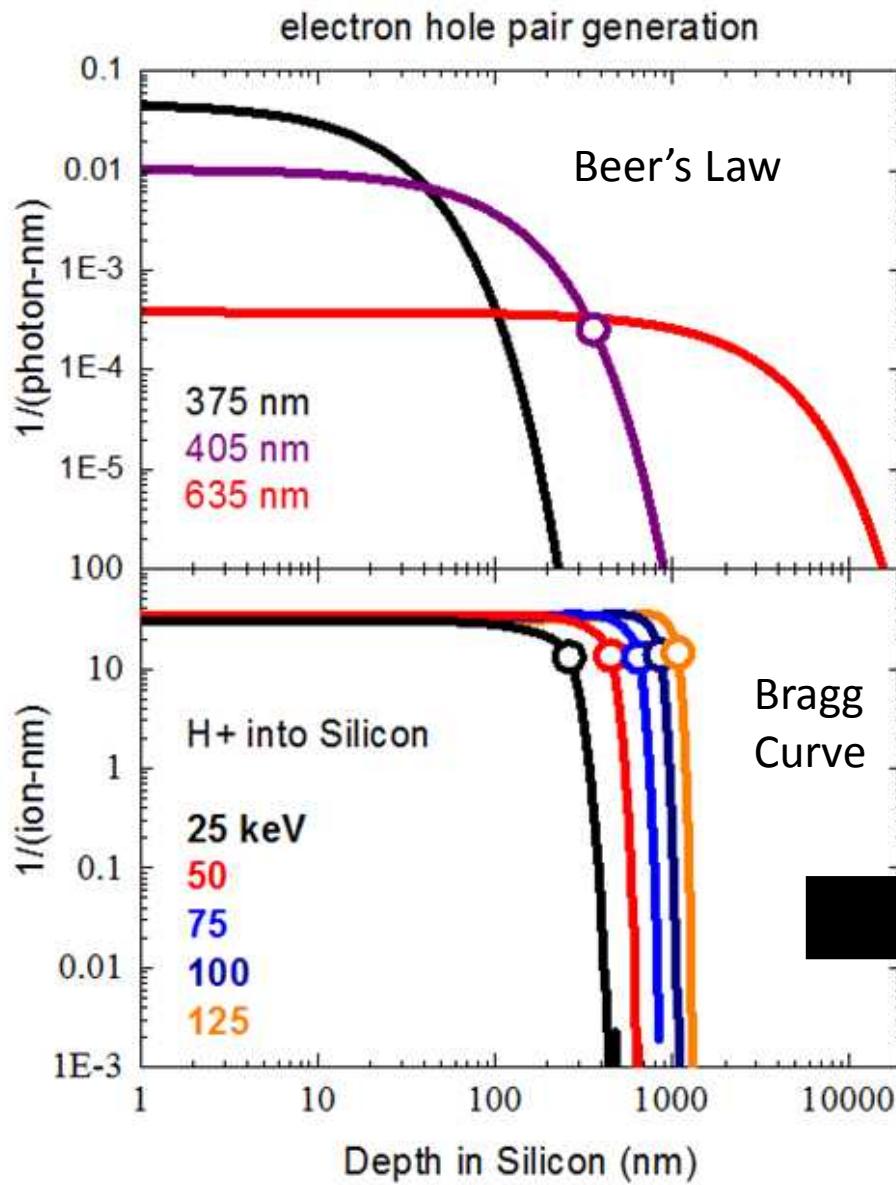
Understand Limiting factors for detection using Photons

1. Develop photon characterization methods
2. Physics-based simulation for detection

We focus on Geiger-mode detectors:
Single EH pair sensitivity



Photons are a damage-free proxy for ions



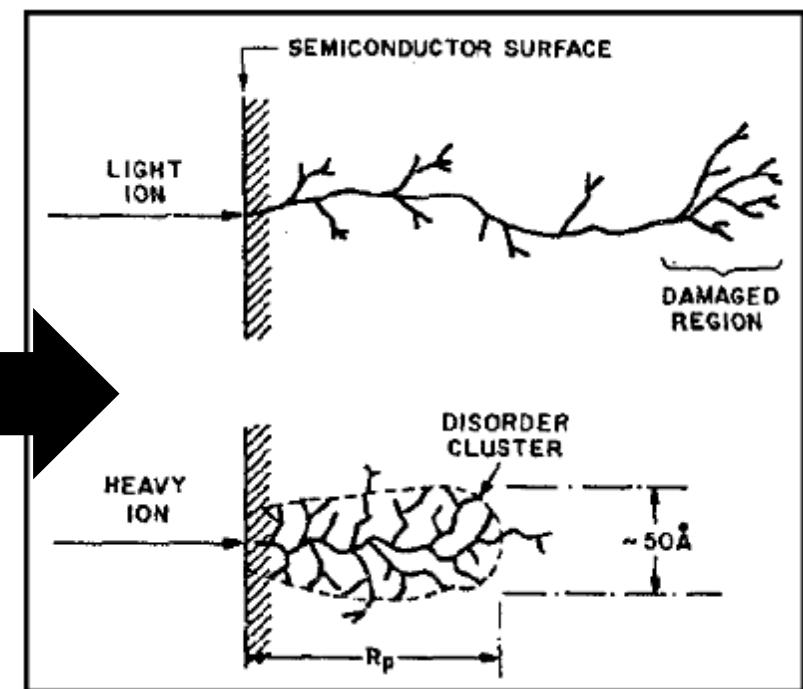
reflection

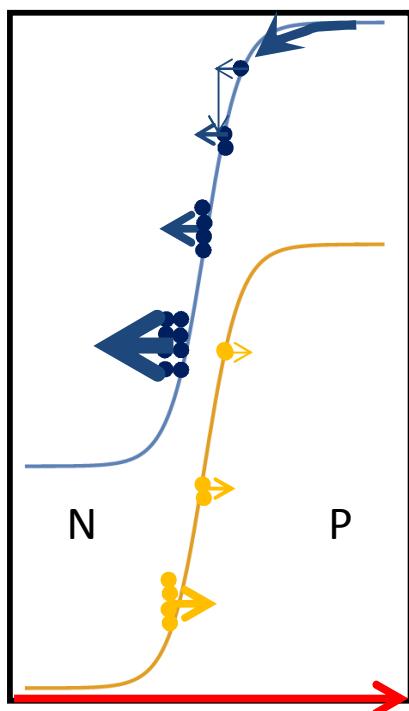
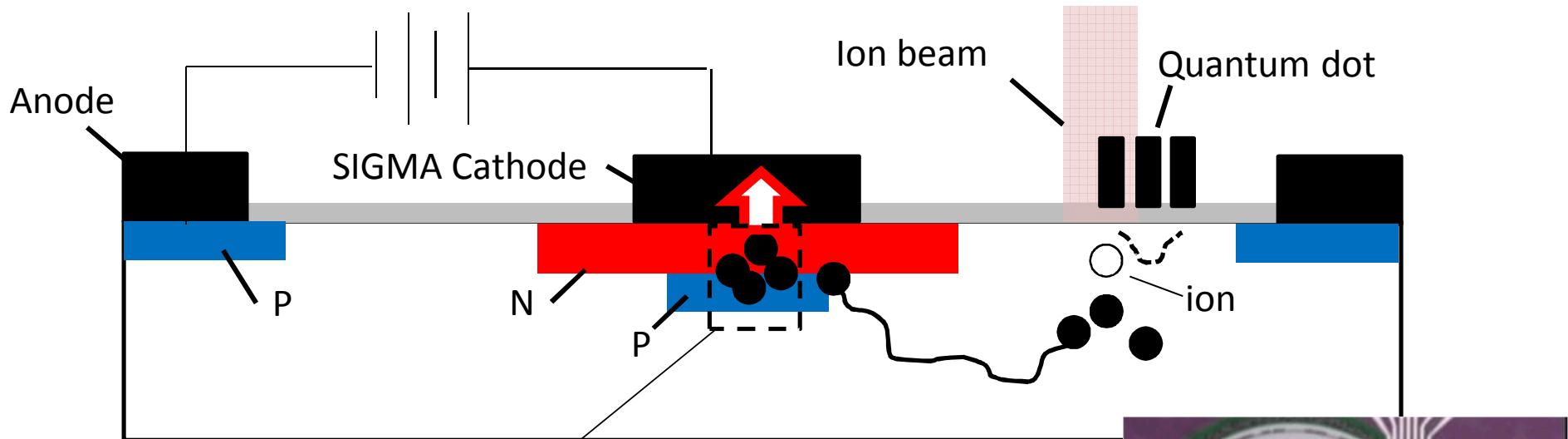
$$GR(z) = F(1 - R)\alpha e^{-\alpha z}$$

Photon flux

Absorption coefficient

This block contains the equation for photon generation rate $GR(z) = F(1 - R)\alpha e^{-\alpha z}$. It includes labels for 'reflection' (pointing to $1 - R$), 'Photon flux' (pointing to F), and 'Absorption coefficient' (pointing to α).

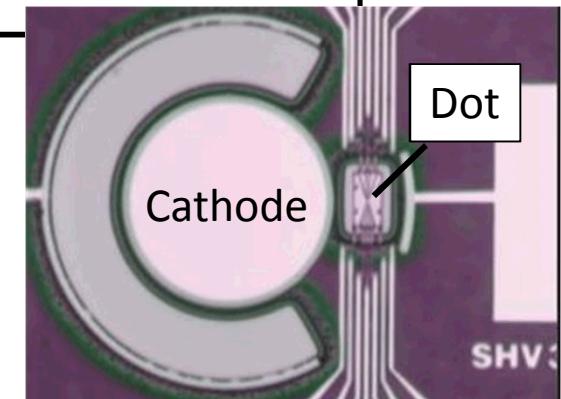




Physics of SIGMA detectors:

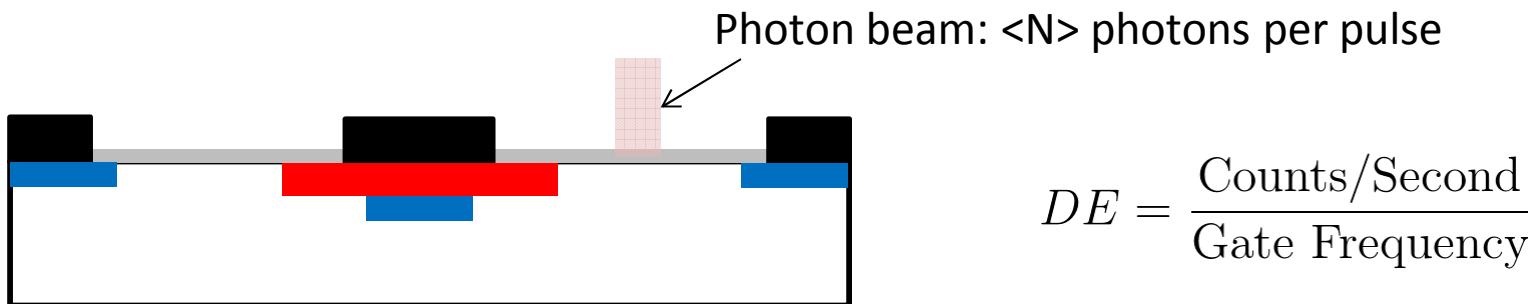
Probability of detection

0. Probability of arrival (Poisson statistics)
1. Quantum yield
2. Probability of diffusion into the breakdown region
3. Breakdown probability

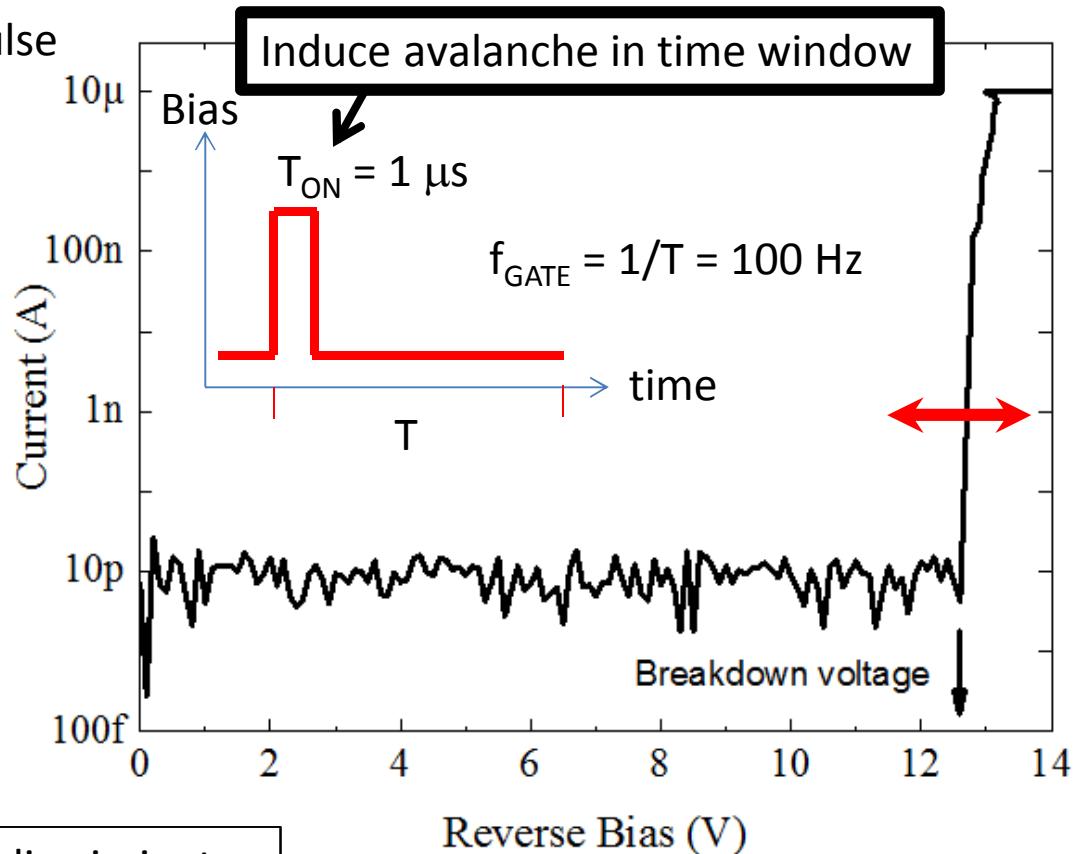
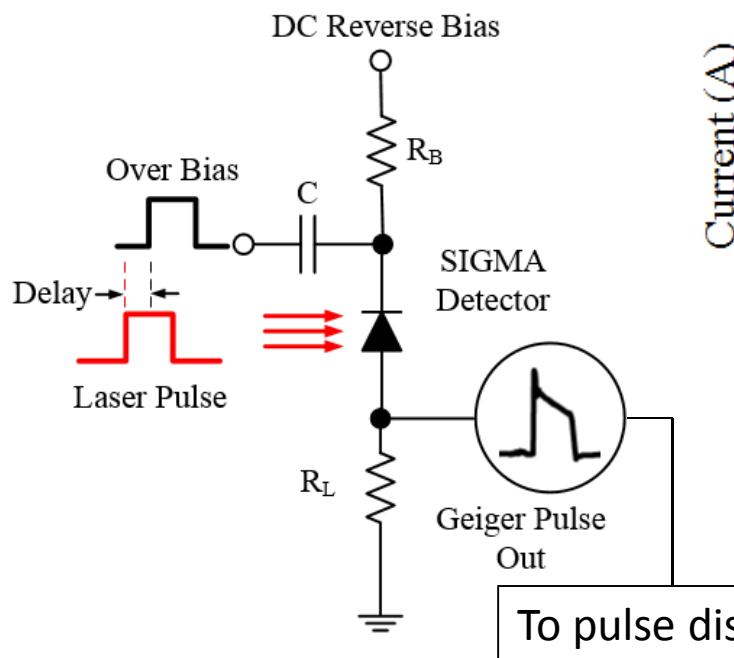


SIGMA Detector

“Geiger Mode” Detection Efficiency using Photon Pulses

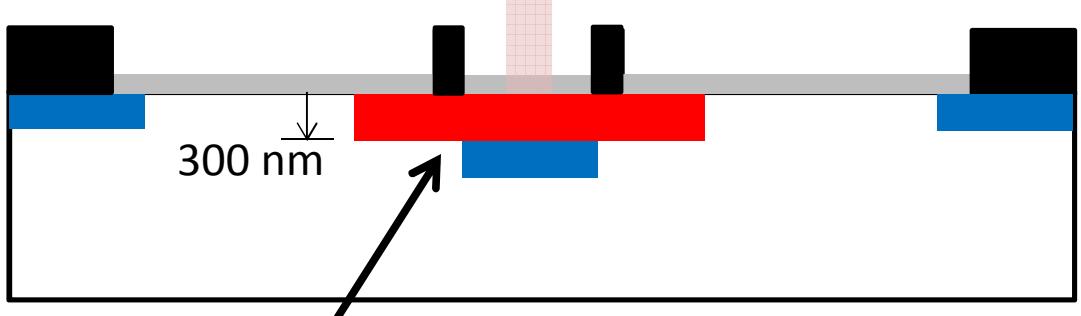


Detect: over-bias for T_{ON} , look for pulse
Turn off to “reset” the device
Count pulses for 1 second



Characterization of Detection Efficiency, Breakdown probability

$\langle N \rangle$ photons per pulse, 405 nm

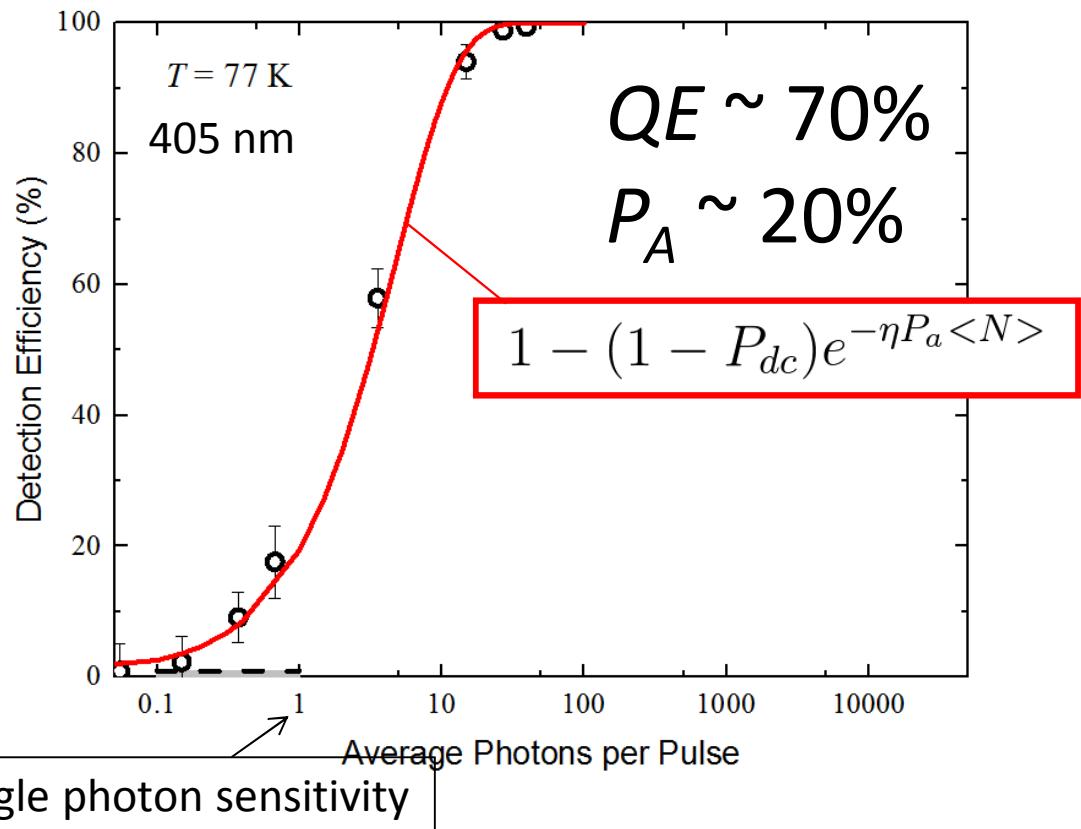
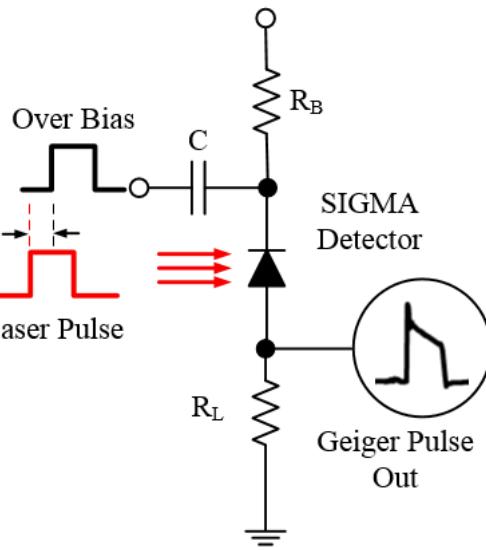


$$DE = \frac{\text{Counts/Second}}{\text{Gate Frequency}}$$

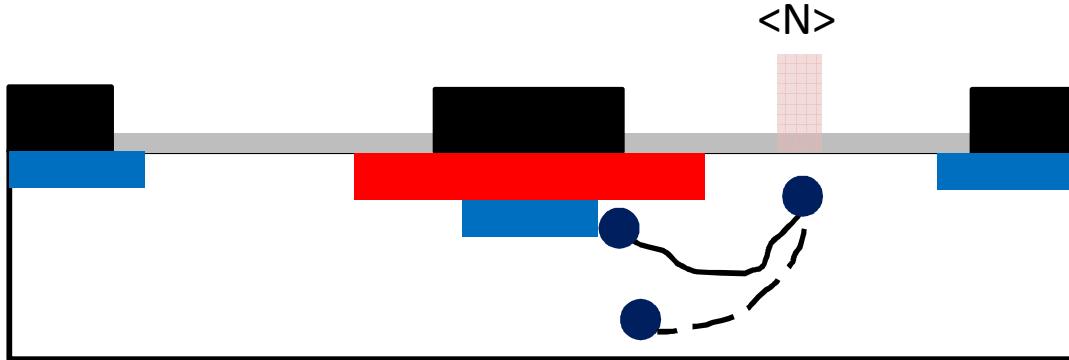
Photon-induced avalanche
Small contribution from diffusion

Delay = 0 ns

DC Reverse Bias



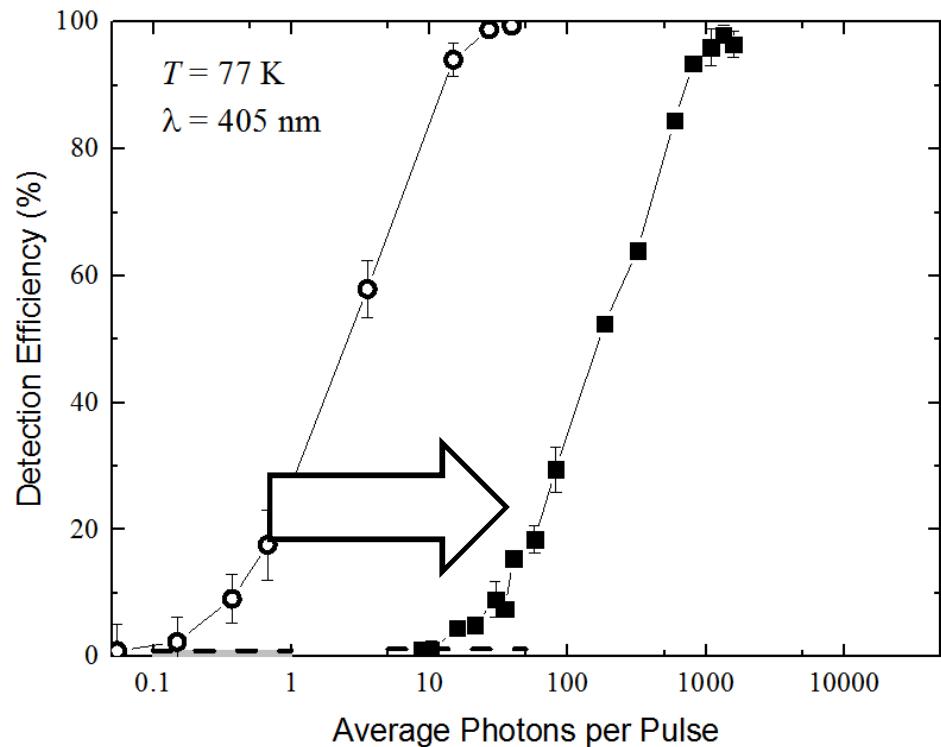
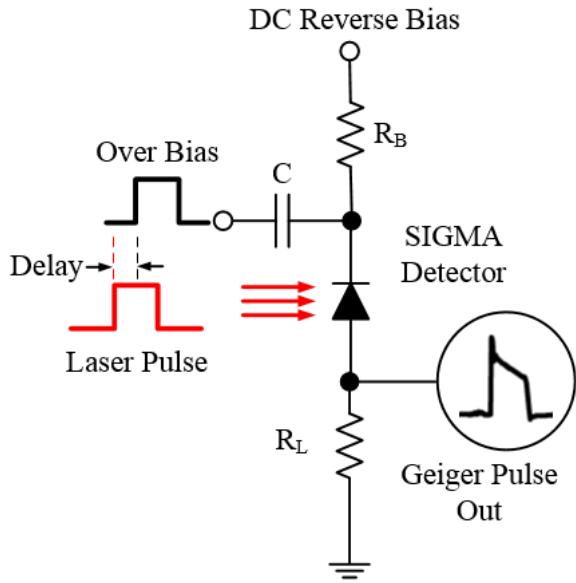
Detection Efficiency farther from the Avalanche region



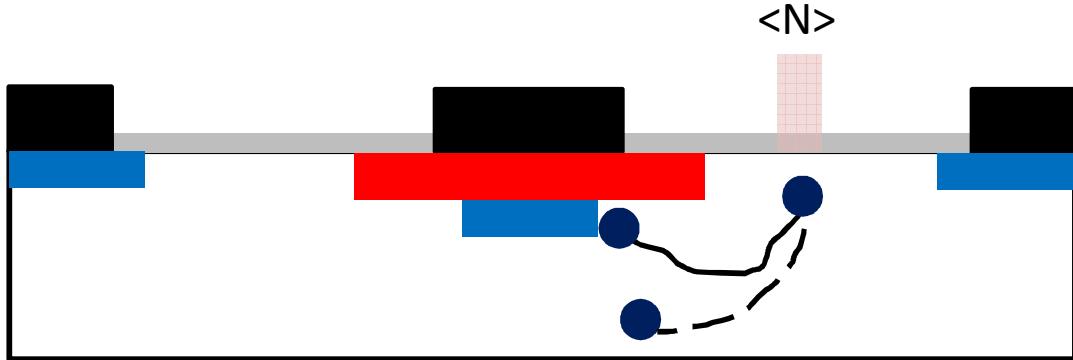
More photons/pulse needed to get same DE

Minority carriers lost to recombination as they diffuse towards avalanche region

Delay = 250 ns

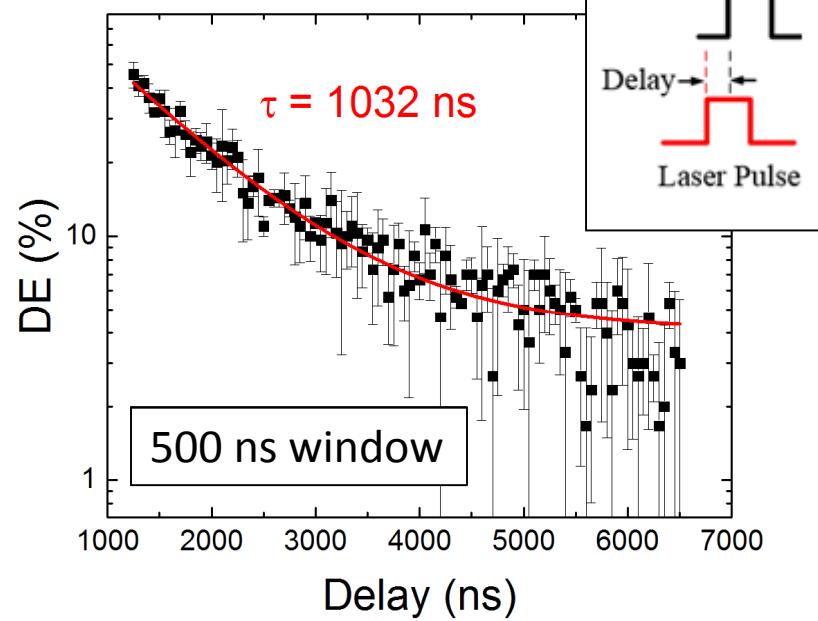
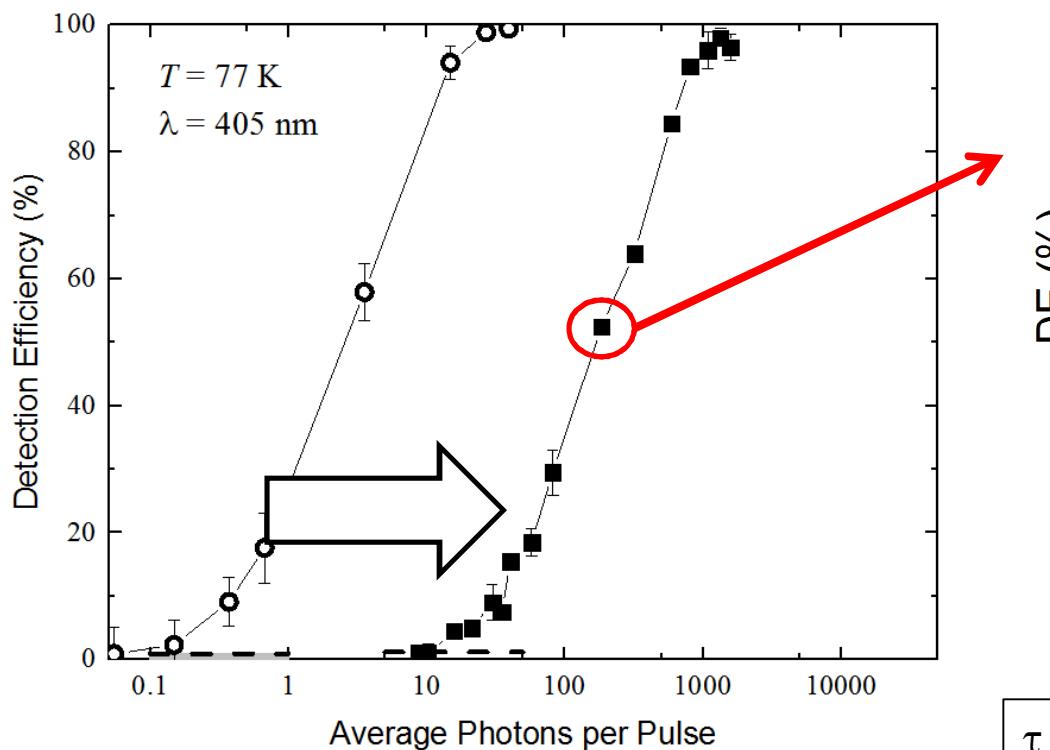


Detection Efficiency, characteristic time of arrival



Minority carriers lost to recombination as they diffuse towards avalanche region

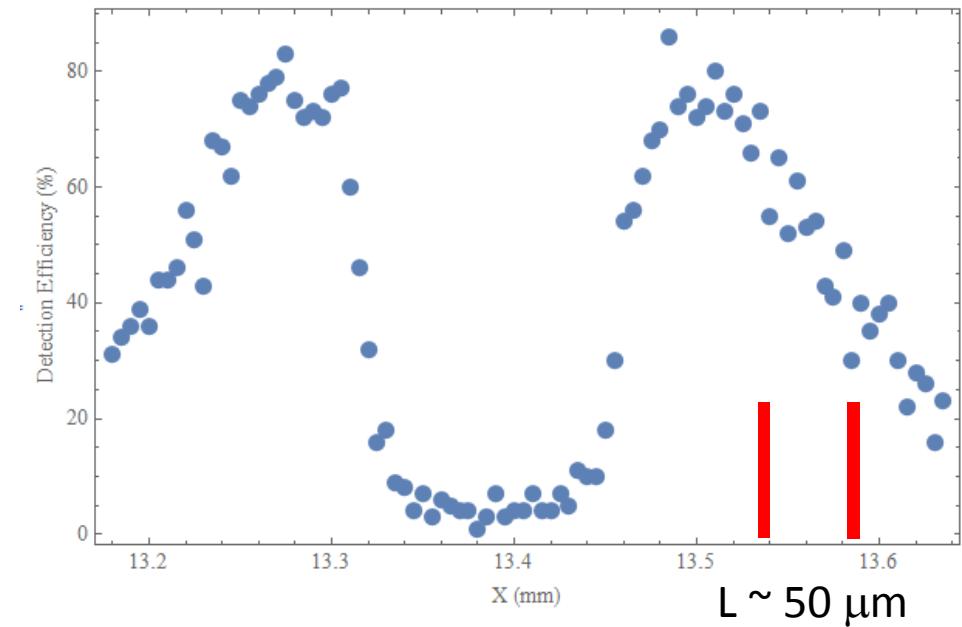
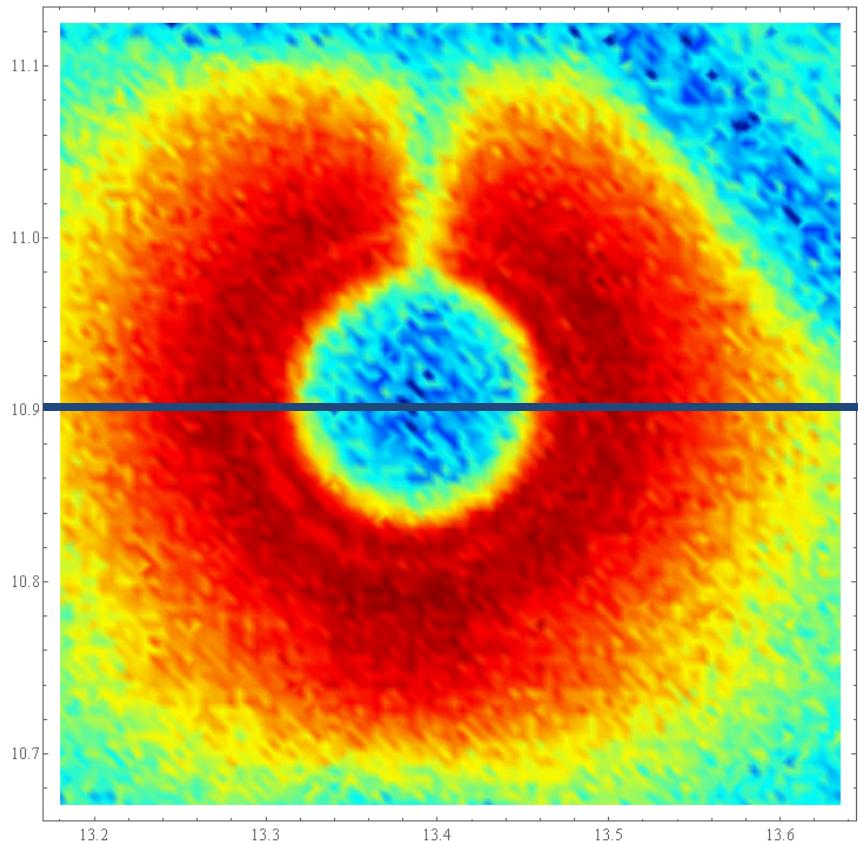
Carriers arrive at different times



$\tau \sim \text{Recombination time}$

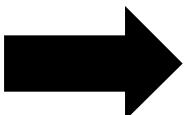
Detection Efficiency in the XY plane: characteristic length for diffusion

$\langle N \rangle = 320$ Photons/pulse, 405 nm, 77 K, Delay = 0 ns, 1 μ s pulse



Decay of Detection Efficiency: minority carrier diffusion

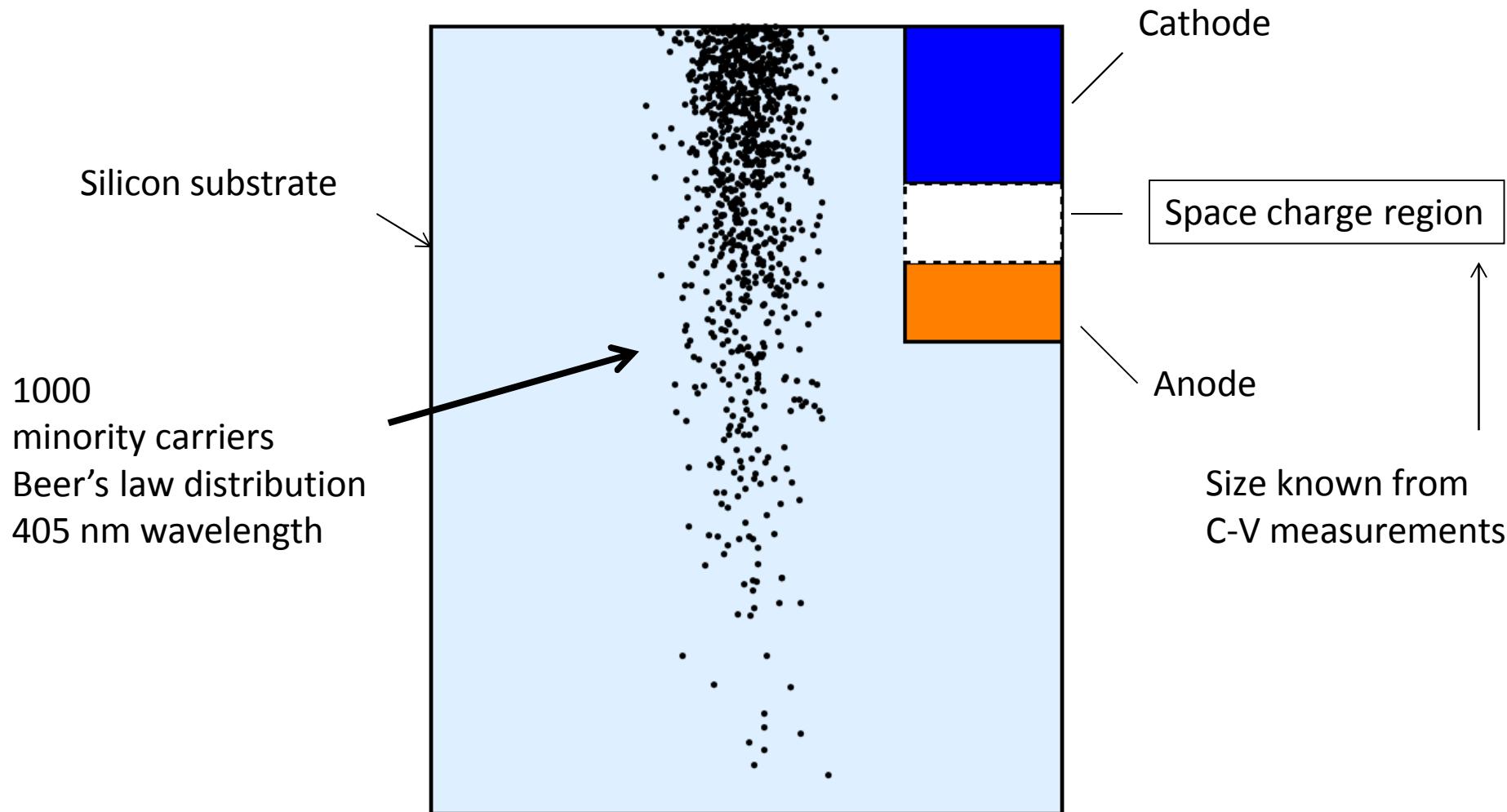
$$D \sim 37 \text{ cm}^2/\text{s}$$
$$\tau \sim 1 \text{ } \mu\text{s}$$



$$L \sim \sqrt{D\tau} \sim 60 \text{ } \mu\text{m}$$

2D Simulations of the SIGMA detector, set up carrier distribution

- Poisson distributed photons in
- Gaussian spot size: 40 microns

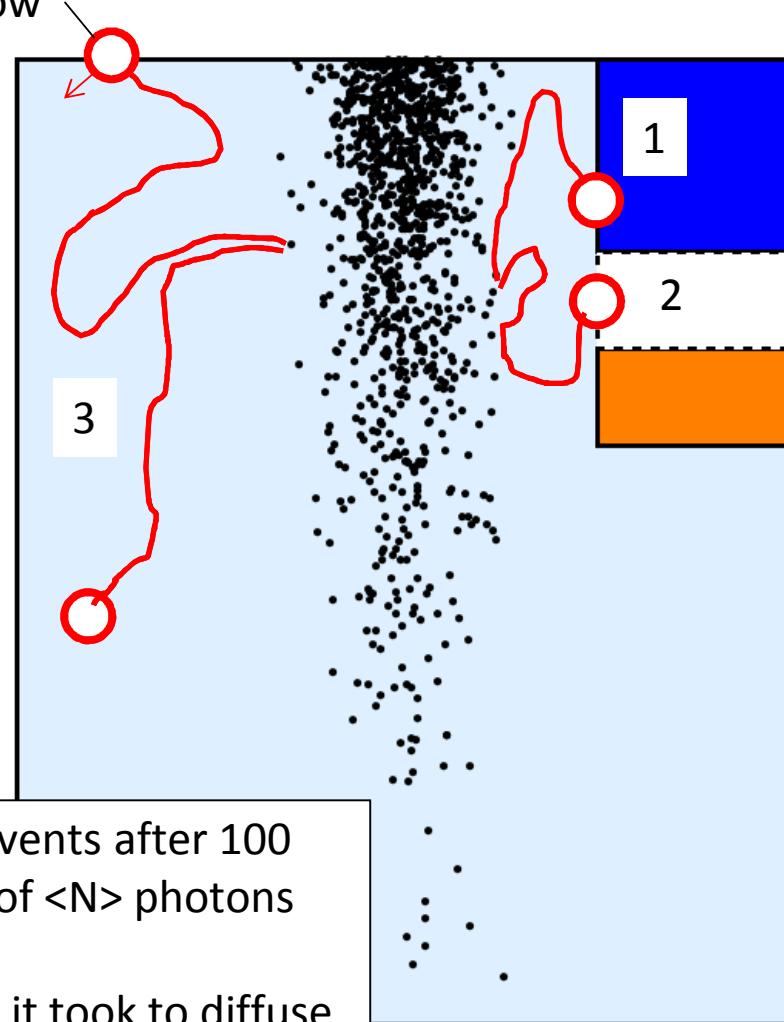


Simulations of the SIGMA Detection Efficiency

Random walk of each carrier up to 3 diffusion lengths ($v_{th} \gg v_D = \mu E$)

Ignore for now

$$L = \sqrt{D\tau}$$
$$\text{mfp} \sim 2D/v_{th}$$
$$v_{th} = \sqrt{2kT/m}$$
$$T = 77 \text{ K}$$
$$D \sim 73 \text{ cm}^2/\text{s}$$
$$\tau \sim 1 \mu\text{s}$$

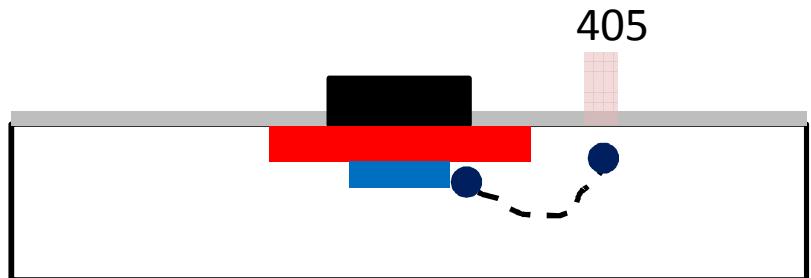
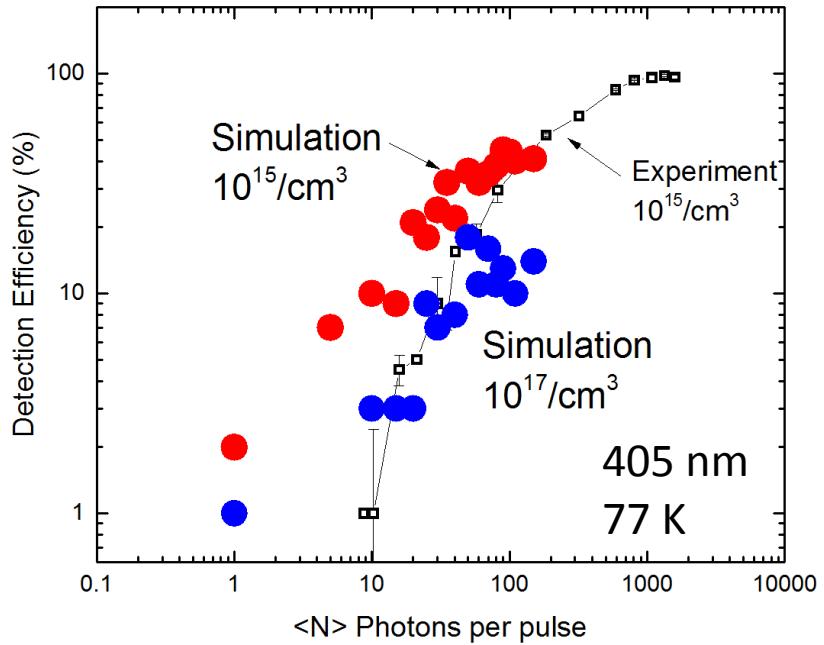


Avalanche region

1. Recombine without an avalanche
2. Avalanche with probability $P_A = 0.2$
3. Recombine in substrate (or interface)

Detection Efficiency versus $\langle N \rangle$ Photons per Pulse

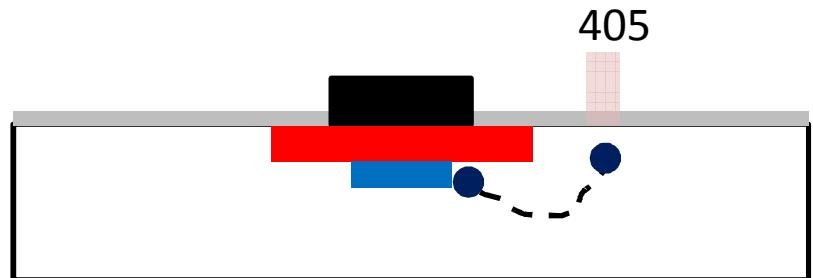
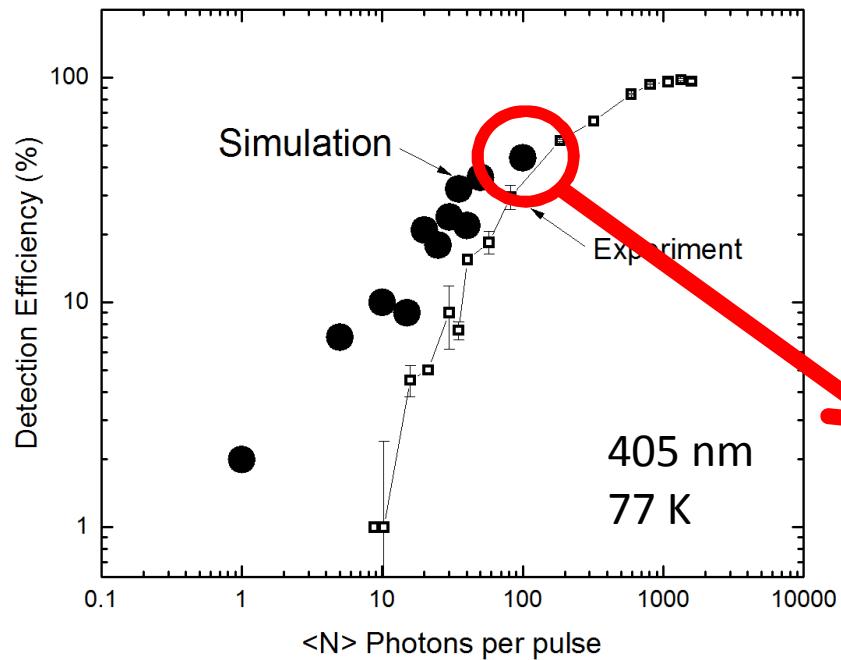
Carriers arriving up to 1 μ s



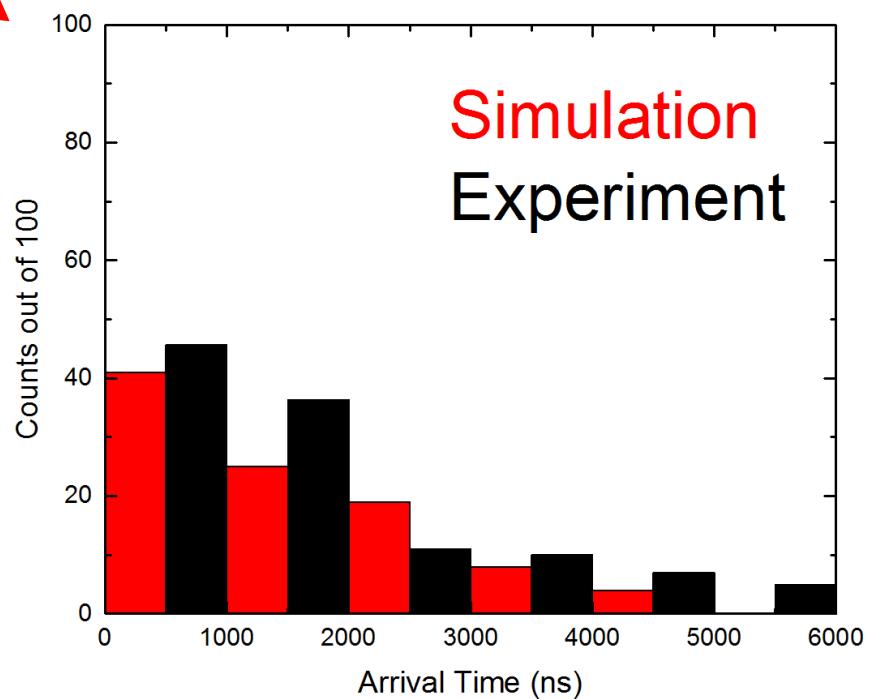
Increase background doping:
Decrease diffusion length

Diffusion/recombination of minority carriers into the detector

Carriers arriving up to 1 μ s

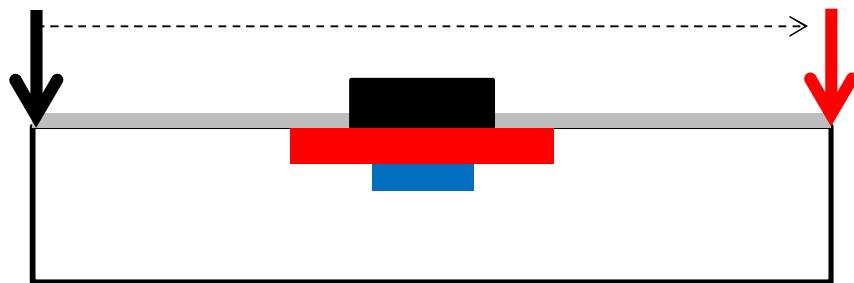


Distribution of arrival times



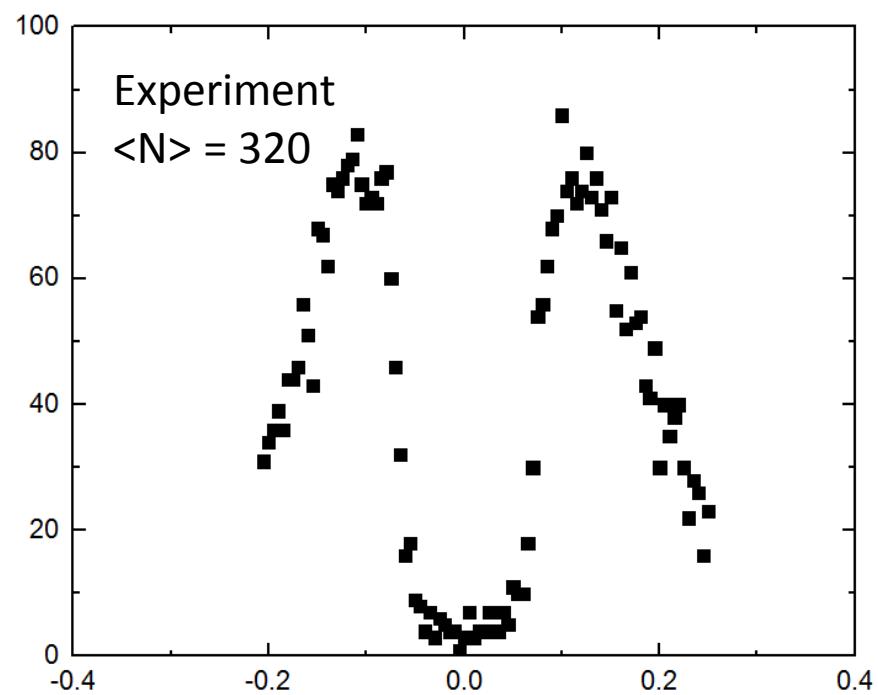
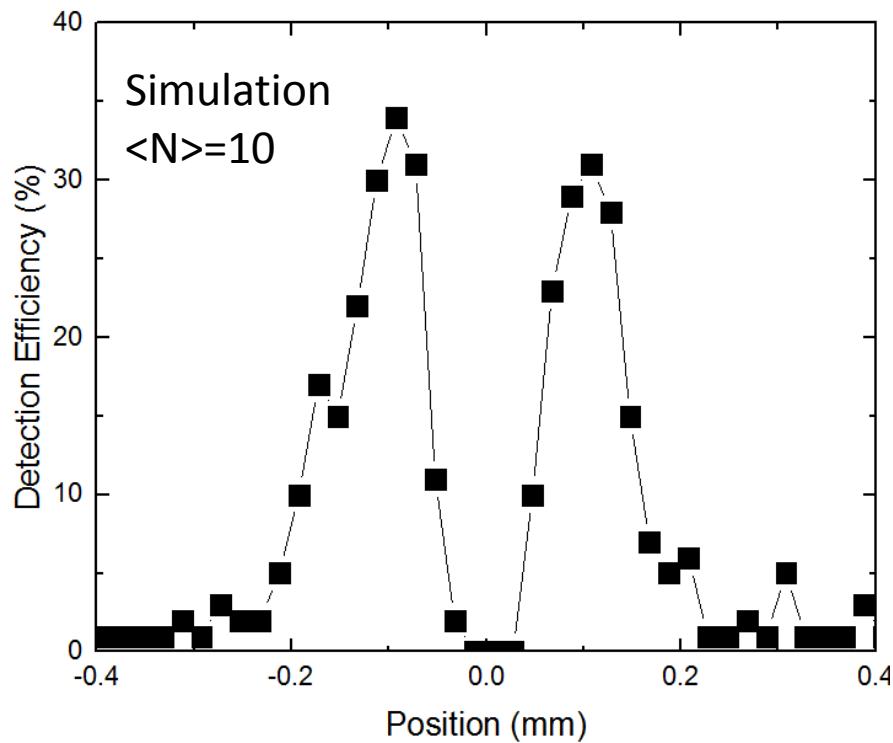
Length scale for position dependent Detection Efficiency

Laser Position



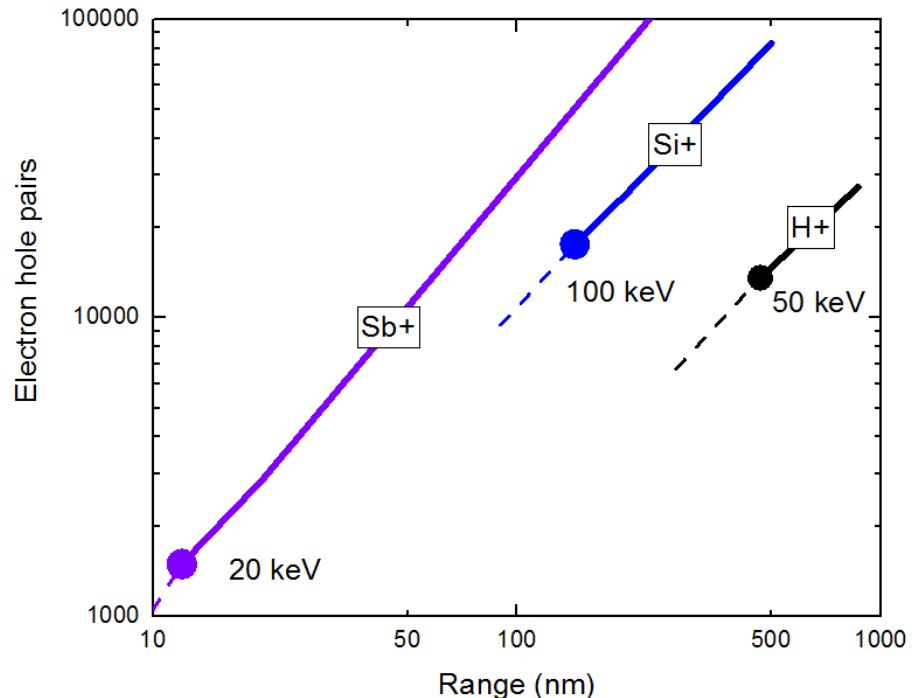
Fixed diffusivity and minority carrier recombination time

DE: count events for carriers arriving within 1 μ s



Damage-free detector performance governed by diffusion and recombination

1. Developed photon-based characterization methods without damage
2. Diffusion-recombination based Simulations of detector performance agree with measurements



What have we learned?

1. Ensure high quality bulk/interface for device
 - a. Deep level traps
 - b. SiO₂/Si interface states
2. Move the detector closer < diffusion length
3. Use an electric field to ensure transit time < recombination time

